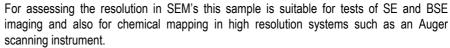
EM Calibration Standards

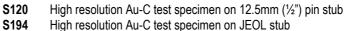
SEM Calibration Specimens

High Resolution Gold on Carbon Test Specimen



Each specimen has a square grid pattern with large crystals in the centre of each grid square and very fine crystals at the edges of each grid. Hence medium and high resolution gap tests are performed on the same specimen. In addition the larger crystals show facets which allow an assessment of the grey level reproduction available at high resolution

Particle sizes range from approx. 5nm to 150nm.



S195 High resolution Au-C test specimen on ISI stub
S196 High resolution Au-C test specimen on Hitachi stub

Available on other stubs to order - please ask



For very high resolution performance testing this specimen has a smaller gold island particle size compared with the S120 specimen above. Suitable for testing at instrument magnifications of 50,000x and above. Particle size range from >2-30nm



S326J Ultra high resolution test specimen (gold) on JEOL stub
 S326I Ultra high resolution test specimen (gold) on ISI stub
 S326H Ultra high resolution test specimen (gold) on Hitachi stub

Available on other stubs to order - please ask

Ultra High Resolution Gold on Carbon <1nm-20nm

Particularly suited for assessing the image quality of ultra high resolution SEM's such as those fitted with field emission sources. A magnification of at least 80,000x is required to clearly resolve the gold particles. Particle size range from<3nm to 50nm.



S328J Ultra high resolution test specimen (gold) on JEOL stub
 S328I Ultra high resolution test specimen (gold) on ISI stub
 S328H Ultra high resolution test specimen (gold) on Hitachi stub

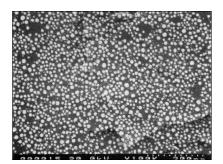
Available on other stubs to order - please ask

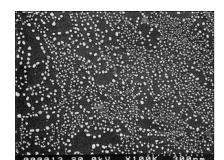
Medium Resolution - Aluminium Tungsten Dendrites

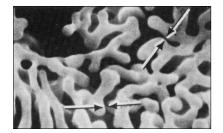
The various spacings created by the dendritic structure give the gap test, and the topographical arrangement of the dendrites leads to the grey level test. The specimen is non-magnetic, vacuum clean, has no adverse reaction to the electron probe and requires no surface coating. It is most useful for working in the probe size range from 25 - 75nm. Supplied unmounted but can easily be attached to a stub with a proprietary stub adhesive.

E-mail: sales@taab.co.uk

S604 SEM medium resolution and grey level test specimen







Phone: +44 (0) 118 981 7775

Fax: +44 (0) 118 981 7881

EM Calibration Standards

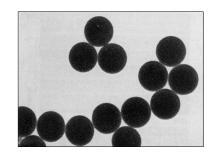
Suspended Polystyrene Latex Spheres

A drop from a suspension of Dow Corning uniform polystyrene latex spheres can provide a useful size check when added to any preparation for TEM or SEM. The spheres can also act as a focus aid or to delineate structure of low slope when the preparation has been shadow cast. The particle sizes are listed below with the standard deviation.

It should be noted that although the standard deviations are very small, the suspension may contain some particles of materially different diameter from the mean. A statistically significant number of latex particles should be included in any micrograph where a size comparison is to be attempted.

It is important not to subject these spheres to excessive irradiation. All solutions are approx. 0.1% weight/volume. Packed in vials of 5ml.

Cat no.	Mean Ø μm	Standard deviation	Approximate particle concentration n/ml	
P404	0.112	0.0010	1.29 x 10 ¹²	
P405	0.132	N/A	7.91 x 10 ¹¹	
P406	0.182	N/A	3.02 x 10 ¹¹	
P407	0.204	0.0019	2.14 x 10 ¹¹	
P408	0.303	0.0019	6.60 x 10 ¹⁰	
P409	0.520	N/A	1.29 x 10 ¹⁰	
P410	0.945	N/A	2.34 x 10 ¹⁰	



Please Note



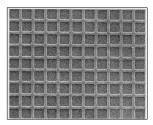
Actual mean diameters and concentrations can vary from batch to batch according to production circumstances. We will supply the nearest matching available spheres.

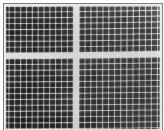
Silicon Test Specimen for SEM & LM

This test specimen is made of a single crystal silicon of overall dimension 5mm x 5mm. It is marked with clearly visible squares of periodicity of $10\mu m$. The dividing lines are about $1.9\mu m$ in width and are formed by electron beam lithography. A broader marking line is written every $500\mu m$. This is a very useful additional feature for Light Microscopy.

This is an excellent specimen for comparing magnification and assessing any distortion in the image field.

S336	Planotec silicon test specimen unmounted	each	
S327	Planotec silicon test specimen on 12.5mm SEM stub	each	
S336/C	Calibration certificate (can be supplied at extra cost if required) Available on other stub types - please specify		
S350	Planotec silicon test specimen for incident light microscop	y each	





E-mail: sales@taab.co.uk